IEC 61207-6

Edition 2.0 2014-11

INTERNATIONAL STANDARD

NORME INTERNATIONALE

Expression of performance of gas analyzers – Part 6: Photometric analyzers

Expression des performances des analyseurs de gaz – Partie 6: Analyseurs photométriques

IEC 61207-6:2014-11(en-fr)

Documents
Document Sharing Hub

Full document details: IEC 61207-6 2014

THIS PUBLICATION IS COPYRIGHT PROTECTED

Copyright © 2014 IEC, Geneva, Switzerland

All rights reserved. Unless otherwise specified, no part of this publication may be reproduced or utilized in any form or by any means, electronic or mechanical, including photocopying and microfilm, without permission in writing from either IEC or IEC's member National Committee in the country of the requester. If you have any questions about IEC copyright or have an enquiry about obtaining additional rights to this publication, please contact the address below or your local IEC member National Committee for further information.

Droits de reproduction réservés. Sauf indication contraire, aucune partie de cette publication ne peut être reproduite ni utilisée sous quelque forme que ce soit et par aucun procédé, électronique ou mécanique, y compris la photocopie et les microfilms, sans l'accord écrit de l'IEC ou du Comité national de l'IEC du pays du demandeur. Si vous avez des questions sur le copyright de l'IEC ou si vous désirez obtenir des droits supplémentaires sur cette publication, utilisez les coordonnées ci-après ou contactez le Comité national de l'IEC de votre pays de résidence.

IEC Central Office
3, rue de Varembé
CH-1211 Geneva 20
Switzerland

Tel.: +41 22 919 02 11
Fax: +41 22 919 03 00
info@iec.ch
www.iec.ch

About the IEC
The International Electrotechnical Commission (IEC) is the leading global organization that prepares and publishes International Standards for all electrical, electronic and related technologies.

About IEC publications
The technical content of IEC publications is kept under constant review by the IEC. Please make sure that you have the latest edition, a corrigenda or an amendment might have been published.

IEC Catalogue - webstore.iec.ch/catalogue
The stand-alone application for consulting the entire bibliographical information on IEC International Standards, Technical Specifications, Technical Reports and other documents. Available for PC, Mac OS, Android Tablets and iPad.

IEC publications search - www.iec.ch/searchpub
The advanced search enables to find IEC publications by a variety of criteria (reference number, text, technical committee,…). It also gives information on projects, replaced and withdrawn publications.

IEC Just Published - webstore.iec.ch/justpublished
Stay up to date on all new IEC publications. Just Published details all new publications released. Available online and also once a month by email.

Electropedia - www.electropedia.org
The world's leading online dictionary of electronic and electrical terms containing more than 30 000 terms and definitions in English and French, with equivalent terms in 14 additional languages. Also known as the International Electrotechnical Vocabulary (IEV) online.

IEC Glossary - std.iec.ch/glossary
More than 55 000 electrotechnical terminology entries in English and French extracted from the Terms and Definitions clause of IEC publications issued since 2002. Some entries have been collected from earlier publications of IEC TC 37, 77, 86 and CISPR.

IEC Customer Service Centre - webstore.iec.ch/csc
If you wish to give us your feedback on this publication or need further assistance, please contact the Customer Service Centre: csc@iec.ch.

A propos de l'IEC
La Commission Electrotechnique Internationale (IEC) est la première organisation mondiale qui élabore et publie des Normes internationales pour tout ce qui a trait à l'électricité, à l'électronique et aux technologies apparentées.

A propos des publications IEC
Le contenu technique des publications IEC est constamment revu. Veuillez vous assurer que vous possédez l'édition la plus récente, un corrigendum ou amendement peut avoir été publié.

Catalogue IEC - webstore.iec.ch/catalogue
Application autonome pour consulter tous les renseignements bibliographiques sur les Normes internationales, Spécifications techniques, Rapports techniques et autres documents de l'IEC. Disponible pour PC, Mac OS, tablettes Android et iPad.

Recherche de publications IEC - www.iec.ch/searchpub

La recherche avancée permet de trouver des publications IEC en utilisant différents critères (numéro de référence, texte, comité d'études,…). Elle donne aussi des informations sur les projets et les publications remplacées ou retirées.

IEC Just Published - webstore.iec.ch/justpublished

Restez informé sur les nouvelles publications IEC. Just Published détaille les nouvelles publications parues. Disponible en ligne et aussi une fois par mois par email.

Electropedia - www.electropedia.org

Le premier dictionnaire en ligne de termes électroniques et électriques. Il contient plus de 30 000 termes et définitions en anglais et en français, ainsi que les termes équivalents dans 14 langues additionnelles. Egalement appelé Vocabulaire Electrotechnique International (IEV) en ligne.

Glossaire IEC - std.iec.ch/glossary
Plus de 55 000 entrées terminologiques électrotechniques, en anglais et en français, extraites des articles Termes et Définitions des publications IEC parues depuis 2002. Plus certaines entrées antérieures extraites des publications des CE 37, 77, 86 et CISPR de l'IEC.

Service Clients - webstore.iec.ch/csc

Si vous désirez nous donner des commentaires sur cette publication ou si vous avez des questions contactez-nous: csc@iec.ch.

Documents
Document Sharing Hub

Full document details: IEC 61207-6 2014

IEC 61207-6

Edition 2.0 2014-11

INTERNATIONAL STANDARD

NORME INTERNATIONALE

Expression of performance of gas analyzers – Part 6: Photometric analyzers

Expression des performances des analyseurs de gaz – Partie 6: Analyseurs photométriques

INTERNATIONAL
ELECTROTECHNICAL
COMMISSION

COMMISSION
ELECTROTECHNIQUE
INTERNATIONALE

PRICE CODE
CODE PRIX **S**

ICS 19.080: 71.040.40

ISBN 978-2-8322-1936-2

Warning! Make sure that you obtained this publication from an authorized distributor.
Attention! Veuillez vous assurer que vous avez obtenu cette publication via un distributeur agréé.

® Registered trademark of the International Electrotechnical Commission
Marque déposée de la Commission Electrotechnique Internationale

Documents
Document Sharing Hub

Full document details: IEC 61207-6 2014

CONTENTS

FOREWORD 3
INTRODUCTION 5
1 Scope and object 6
2 Normative references 6
3 Terms and definitions 7
4 Procedure for specification 13
4.1 General 13
4.2 Specification of essential ancillary units and services 13
4.3 Additional terms related to the specification of performance 13
5 Recommended standard values and range of influence quantities 14
6 Procedures for compliance testing 14
6.1 Verification of performance values 14
6.2 Test equipment 14
6.3 Simulation of duct width 14
6.4 Testing procedures 15
6.4.1 General 15
6.4.2 Linearity uncertainty 15
6.4.3 Interference uncertainty 15
6.4.4 Delay time, rise and fall time 16
Annex A (normative) Techniques and systems of photometric analysis 17
Annex B (informative) Methods of preparation of water-vapor in test gases 20
Bibliography 22

Figure A.1 – Wavelength range for photometric measurements 17
Figure A.2 – Analysis systems for gases 17
Figure A.3 – Test apparatus to apply gases and water vapor to analysis systems 18
Figure A.4 – Test apparatus to simulate duct conditions for in-situ/across-duct analyzers 19

Documents
Document Sharing Hub
Full document details: IEC 61207-6 2014

INTERNATIONAL ELECTROTECHNICAL COMMISSION

EXPRESSION OF PERFORMANCE OF GAS ANALYZERS –

Part 6: Photometric analyzers

FOREWORD

1) The International Electrotechnical Commission (IEC) is a worldwide organization for standardization comprising all national electrotechnical committees (IEC National Committees). The object of IEC is to promote international co-operation on all questions concerning standardization in the electrical and electronic fields. To this end and in addition to other activities, IEC publishes International Standards, Technical Specifications, Technical Reports, Publicly Available Specifications (PAS) and Guides (hereafter referred to as "IEC Publication(s)"). Their preparation is entrusted to technical committees; any IEC National Committee interested in the subject dealt with may participate in this preparatory work. International, governmental and non-governmental organizations liaising with the IEC also participate in this preparation. IEC collaborates closely with the International Organization for Standardization (ISO) in accordance with conditions determined by agreement between the two organizations.
2) The formal decisions or agreements of IEC on technical matters express, as nearly as possible, an international consensus of opinion on the relevant subjects since each technical committee has representation from all interested IEC National Committees.
3) IEC Publications have the form of recommendations for international use and are accepted by IEC National Committees in that sense. While all reasonable efforts are made to ensure that the technical content of IEC Publications is accurate, IEC cannot be held responsible for the way in which they are used or for any misinterpretation by any end user.
4) In order to promote international uniformity, IEC National Committees undertake to apply IEC Publications transparently to the maximum extent possible in their national and regional publications. Any divergence between any IEC Publication and the corresponding national or regional publication shall be clearly indicated in the latter.
5) IEC itself does not provide any attestation of conformity. Independent certification bodies provide conformity assessment services and, in some areas, access to IEC marks of conformity. IEC is not responsible for any services carried out by independent certification bodies.
6) All users should ensure that they have the latest edition of this publication.
7) No liability shall attach to IEC or its directors, employees, servants or agents including individual experts and members of its technical committees and IEC National Committees for any personal injury, property damage or other damage of any nature whatsoever, whether direct or indirect, or for costs (including legal fees) and expenses arising out of the publication, use of, or reliance upon, this IEC Publication or any other IEC Publications.
8) Attention is drawn to the Normative references cited in this publication. Use of the referenced publications is indispensable for the correct application of this publication.
9) Attention is drawn to the possibility that some of the elements of this IEC Publication may be the subject of patent rights. IEC shall not be held responsible for identifying any or all such patent rights.

International Standard IEC 61207-6 has been prepared by sub-committee 65B: Measurement and control devices, of IEC technical committee 65: Industrial-process measurement, control and automation.

This second edition cancels and replaces the first edition published in 1994. This edition constitutes a technical revision.

The major changes with respect to the previous edition are as follows.

– All references (normative and informative) have been updated, deleted or added to as appropriate.
– All the terms and definitions relating to the document have been updated where appropriate.
– New definitions have been added for generic photometric equipment and measurements.

AVA Documents
Document Sharing Hub

Full document details: IEC 61207-6 2014

– All references to “errors” have been replaced by “uncertainties” and appropriate updated definitions applied.
– Figures A.1, A.2 and A.4 have been updated.

The text of this standard is based on the following documents:

FDIS	Report on voting
65B/947/FDIS	65B/956/RVD

Full information on the voting for the approval of this standard can be found in the report on voting indicated in the above table.

This publication has been drafted in accordance with the ISO/IEC Directives, Part 2.

A list of all parts in the IEC 61207 series, published under the general title *Expression of performance of gas analyzers*, can be found on the IEC website.

The committee has decided that the contents of this publication will remain unchanged until the stability date indicated on the IEC web site under "http://webstore.iec.ch" in the data related to the specific publication. At this date, the publication will be

- reconfirmed,
- withdrawn,
- replaced by a revised edition, or
- amended.

Documents
Document Sharing Hub

Full document details: IEC 61207-6 2014

INTRODUCTION

Photometric analyzers utilize detectors which respond to wavelengths in the ultraviolet, visible and infrared part of the electromagnetic spectrum within the wavelength range 0,1 μm to 50 μm (see Figure A.1). Within this range of wavelengths, many gases have absorption and/or emission bands. Analyzers designed to utilize these bands employ several techniques, including sensing of specific absorbed radiation by the sample gas or emitted radiation from the gas sample after artificial excitation. The volume of gas measured may be contained within a sample cell and this sample may or may not be conditioned, or (for in-situ analyzers) the concentration may be directly measured within the sample gas itself (see Figure A.2).

Documents
Document Sharing Hub

Full document details: IEC 61207-6 2014

EXPRESSION OF PERFORMANCE OF GAS ANALYZERS –

Part 6: Photometric analyzers

1 Scope and object

This part of IEC 61207 applies to all aspects of analyzers using photometric techniques for the measurement of concentration of one or more components in a mixture of gases or vapors. It should be used in conjunction with IEC 61207-1.

For photometric analyzers utilizing tuneable semiconductor laser absorption spectroscopy (TSLAS) for gas measurements, IEC 61207-7 should also be referred to.

This part of IEC 61207 applies to analyzers using non-dispersive and dispersive wavelength selection and using absorption, emission, wavelength derivative or scattering techniques.

It applies to analyzers which receive either a conditioned or unconditioned sample of gas either under vacuum, at ambient pressure or pressurized.

It applies to analyzers which measure gas concentrations directly within the sample gas.

The object of this part is:

– to specify the terminology and definitions related to the functional performance of gas analyzers, utilizing a photometric analyzer, for the continuous measurement of gas or vapor concentration in a source gas;
– to unify methods used in making and verifying statements on the functional performance of such analyzers;
– to specify what tests should be performed to determine the functional performance and how such tests should be carried out;
– to provide basic documents to support the application of standards of quality assurance ISO 9001.

2 Normative references

The following documents, in whole or in part, are normatively referenced in this document and are indispensable for its application. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

IEC 60079-29-1, *Explosive atmospheres – Part 29-1: Gas detectors – Performance requirements of detectors for flammable gases*

IEC 60079-29-4, *Explosive atmospheres – Part 29-4: Gas detectors – Performance requirements of open path detectors for flammable gases*

IEC 60654 (all parts), *Operating conditions for industrial-process measurement and control equipment*

IEC 61207-1, *Expression of performance of gas analyzers – Part 1: General*

Documents
Document Sharing Hub

Full document details: IEC 61207-6 2014

IEC 61207-7, *Expression of performance of gas analyzers – Part 7: Tuneable semiconductor laser gas analyzers*

ISO 9001, *Quality management systems – Requirements*

3 Terms and definitions

For the purposes of the present document, the following terms and definitions apply.

NOTE The following definitions and examples of equipment and measuring techniques are for illustration and do not constitute a complete list of all possible measurement types. See Figure A.1 for the relationship between the different optical wavelength ranges.

3.1
light source
device that emits light within the wavelength range 0,1 μm to 50 μm

Note 1 to entry: A source may be, but is not limited to: a gas or solid state laser, semiconductor laser diode, light emitting diode, electric discharge source or incandescent filament.

3.2
light detector
device that is sensitive to light and that may be used to detect light within the wavelength range 0,1 μm to 50 μm

Note 1 to entry: A light detector may be, but is not limited to: a photomultiplier tube, semiconductor device (photovoltaic or photoconductive) such as a photodiode, avalanche photodiode or charge coupled device (CCD) and, additionally, in the infrared region: pyroelectric detector, bolometer or thermopile.

3.3
wavelength selection
wavelength or range of wavelengths selected for use in particular measurement

Note 1 to entry: A suitable wavelength transmission range may be selected by using an appropriate means including a band-pass optical filter or dispersive element such as a diffraction grating.

Note 2 to entry: The wavelength from the light source may be tuned or modulated such as by using the current or temperature for a semiconductor laser diode, varying the temperature of an incandescent source or varying the input angle to a band-pass filter.

3.4
optical sample cell
enclosed volume where the optical measurement of the sample gas takes place

Note 1 to entry: The optical measurement may take place by measuring the absorption or emission of the analyte after light of a suitable wavelength has been passed through an optical sample cell.

Note 2 to entry: The sample cell shall have some means of gas inlet and outlet, which may be via piping for flow or pressure driven systems or via diffusion through a mechanical filter.

Note 3 to entry: The cell may require a high integrity seal from the outside environment for extractive systems other than the gas inlet and outlet means.

Note 4 to entry: Cell windows of the appropriate optical transmission band are required for the light ingress and egress.

Note 5 to entry: Internal mechanical or optical features of the sample cell may be used to decrease stray light interference or to direct or concentrate the light where appropriate.

Note 6 to entry: The cell is designed to give an optical path length which is appropriate to the analyte and range required.

Documents
Document Sharing Hub
Full document details: IEC 61207-6 2014

3.5
multi-pass sample cell
optical sample cell with increased effective absorption light path achieved by multiple reflections within the optical cavity of the sample cell

Note 1 to entry: The effect of the multi-pass cell is to increase the sensitivity of the measurement for the same total cell length.compared to a single pass cell.

Note 2 to entry: Typical design models used include Herriott or White cells.

3.6
environmental monitoring gas analyzer
photometric gas analyzer used for environmental monitoring purposes

3.6.1
open path monitoring
optical measurement where no containment for the sample gas is required

Note 1 to entry: This may be across a large space or an external measurement path.

Note 2 to entry: Typically, the light source and detector are separated by a distance and aligned to give a straight line absorption pathway.

Note 3 to entry: The net absorption will be the integrated effect across the whole of the absorption path length.

3.6.2
point monitoring
monitoring giving localized gas concentration information

Note 1 to entry: This gives monitoring information from a localized position rather than averaged data across an extended path length as per 3.6.1.

3.7
in-situ analyzer
analyzer where the volume of gas sensed, that is gas within the measuring path for a photometric analyzer, is situated within the process source fluid

Note 1 to entry: An in-situ analyzer may contain a fixed-length measuring cell within the duct and hence its calibration is not affected by the dimensions of the duct.

3.7.1
across duct or cross stack analyzer
analyzer where the measuring path is formed by the entire width of a process duct or stack

Note 1 to entry: The radiation source and detector can be mounted on opposite sides of the duct, or both can be mounted on the same side and a retroreflector employed. Where the retroreflector is within the duct, the analyzer is of the in-situ type.

3.7.2
across process line or pipe analyzer
analyzer where the measuring path is formed by the entire width of a process pipe

Note 1 to entry: The radiation source and detector can be mounted on opposite sides of the pipe, or both can be mounted on the same side and a retroreflector employed. Where the retroreflector is within the duct, the analyzer is of the in-situ type.

3.7.3
across firebox or other open process analyzer
analyzer where the measuring path is formed by the entire width of a firebox or other open process path

3.7.4
inside process line or duct analyzer
analyzer where the measuring path or point is inside the process duct itself.

Documents
Document Sharing Hub
Full document details: IEC 61207-6 2014

3.8
extractive analyzer
analyzer which receives a continuous stream of gas withdrawn from a process by a sample handling system

3.8.1
close coupled extractive analyzer
gas analyzer where the sensors are mounted at, or as close as possible to, the process take off point with a short extraction loop (typically <1 m) and with minimal sample handling, typically just particulate filtration

3.8.2
remote extractive analyzer
gas analyzer which is situated remote from the process to be measured (typically >1 m)

Note 1 to entry: This may require further sample handling, including maintaining the sample at an elevated temperature to avoid condensation.

3.9
sample-handling system
system which connects one or more process analyzers with the source fluid and the disposal points

Note 1 to entry: The performance of this system is not dealt with in this part except for dilution sampling systems.

3.10
dilution sampling system
system which samples process fluid and adds a diluent to the sample stream prior to measurement

Note 1 to entry: This type of system generally applies calibration gas prior to the dilution point and hence the dilution system is treated as part of an in-situ analyzer for the purposes of this part of IEC 61207.

3.11
conditioned sample
continuous stream of gas withdrawn from the source gas and filtered, cooled, and dried to within specified limits before application to a sampling analyzer

3.12
heated sample
continuous stream of gas withdrawn from the source gas, which may or may not be filtered but is maintained at a temperature above its dew-point, including within the analyzer

3.13
opacity
absorption of radiation, at the wavelengths used for measurement, by components of the sample gas, other than the component to be measured

Note 1 to entry: For example, this may be produced by dust or other contamination.

3.14
essential ancillary units
units without which the analyzer will not operate, e.g. ancillary electronic units processing sensor signals to produce the reading, dilution sampling system, air purge or other optical cleaning system, automatic calibration system, temperature or pressure compensation system

Documents
Document Sharing Hub

Full document details: IEC 61207-6 2014

3.15
analyzers using light absorption
analyzers which detect the amount of light absorbed by a gas of interest from a light source through a sample gas to a light detector at a particular wavelength or wavelength range in order to determine its concentration

3.15.1
infrared absorption analyzer
electro-optical instrument consisting of a single source or multiple sources of infrared radiation and one or more infrared detectors separated from the source by a measuring path, wherein the specific spectral absorption of the component of interest is determined within the wavelength range 0,7 μm to 50 μm

Note 1 to entry: For the purpose of this part of IEC 61207, the analyzer is adjusted by the manufacturer to select only the spectral band(s) at which the component to be determined has its characteristic absorption, and the measuring path dimensions are appropriate for the rated range of concentration and application of the analyzer.

Note 2 to entry: Specific spectral sensitivity is obtained by a selective component such as a selective source, selective detector or selective filter, gas-filled cell or dispersive element, or any combination of these components.

3.15.2
ultraviolet (visible) absorption analyzer
analyzer as defined in 3.15.1 but where the spectral absorption of the component determined occurs at wavelengths between 0,1 μm and 0,7 μm, hence the source(s), detector(s) and other optical components operate in the visible light or ultraviolet part of the electromagnetic spectrum

Note 1 to entry: The visible part of the spectrum is included in this definition for ease of reference.

3.15.3
dual-beam analyzer
analyzer whereby the radiation passage through the measured gas and a reference gas follows separate physical paths

3.15.4
single-beam analyzer
analyzer whereby the radiation follows a single path through the sample gas, and measuring and reference signals are derived from wavelength selection (see 3.3 for example), or for a single-beam single-wavelength analyzer, no reference signal is generated

3.15.5
dual-wavelength filter-correlation analyzer
analyzer where measuring and reference signals are derived by optical filter wavelength selection within and outside an absorption band respectively

Note 1 to entry: These two signals are processed to derive a concentration value.

3.15.6
gas filter correlation analyzer
analyzer where measuring and reference signals are derived by utilizing a cell (gas filter) filled with the gas to be measured to absorb selectively radiation corresponding to the fine structure of the absorption line spectrum of that gas and another, otherwise identical cell, filled with a non-absorbing reference gas

Note 1 to entry: The two signals are processed to derive a concentration value.

Note 2 to entry: The gas-filled filter component may be part of the detector.

Documents
Document Sharing Hub
Full document details: IEC 61207-6 2014

3.15.7
direct absorption analyzer
absorption measurements where the change in signal magnitude at the light detector due to optical absorption by the gas of interest is directly used as a means to determine the concentration of the gas of interest in a sample gas

3.15.8
wavelength derivative analyzer
analyzer which measures gas-component concentrations using wavelength modulation of the radiation, and thereby uses the first derivative or second derivative of intensity versus wavelength to measure the shape of the absorption band

3.15.9
tuneable semiconductor laser absorption spectroscopy
TSLAS
method of gas measurement using a tuneable semiconductor laser diode to determine the amount of light absorbed after transmission through a sample gas

Note 1 to entry: The light output wavelength from a laser diode may be tuned by using temperature and/or drive current of the laser diode. This allows the laser output wavelength to be scanned across an individual absorption band or bands of an absorbing gas species. The absorption information gained may be used to determine the gas concentration of the target species.

Note 2 to entry: In addition to note 1, a higher frequency modulation may be superimposed onto this lower frequency scan across the absorption band, in order to obtain enhanced speciation and/or measurement accuracy.

3.15.10
wavelength modulation spectroscopy
WMS
technique using TSLAS (see 3.15.9) where the laser optical frequency is typically modulated in the 10 kHz to 1 000 kHz region, usually in addition to a much lower frequency scan over the gas absorption line of interest

Note 1 to entry: The modulated laser beam is passed through the sample gas and the transmitted beam is detected using a fast photo-detector and the signal is then processed (demodulated) to obtain the gas absorption profile with high signal to noise ratio.

3.15.11
frequency modulation spectroscopy
FMS
technique similar to WMS (see 3.15.10) however, in FMS the optical frequency of the laser is modulated at a much higher frequency (tens of MHz to GHz region)

Note 1 to entry: The higher frequency modulation of FMS compared to WMS provides a performance improvement.

3.15.12
cavity ring down spectroscopy
method of gas measurement using the decay profile of optical energy with time within a multi-pass sample cell

Note 1 to entry: Laser light is coupled into an optical cavity usually using highly reflective mirrors for the intended wavelength.

Note 2 to entry: The decay of optical energy in the cell with time is monitored. The decay profile will be a function both of the reflectivity of the cell and any absorption taking place due to the presence of an absorbing sample gas.

Note 3 to entry: Due to the high reflectivity of the cavity, long effective absorption path lengths are obtained, leading to high sensitivity measurements.

3.15.13
fourier transform infrared (FTIR) analyzer
analyzer using an infrared spectrum as a means of calculating the absorption by the gas of interest

AVA Documents
Document Sharing Hub
Full document details: IEC 61207-6 2014

Note 1 to entry: The infrared spectrum is obtained by first collecting an interferogram of a sample signal using an interferometer, and then performing a Fourier Transform on the interferogram to obtain the absorption spectrum.

3.15.14
photoacoustic gas analyzer
analyzer for gas measurement using the acoustic signal generated by thermally induced pressure waves caused by the absorption of optical energy by gas molecules in a sample gas

Note 1 to entry: The sample gas is excited by a modulated light source, but instead of directly measuring the light absorbed, the signal due to thermally induced pressure waves caused by the absorption of optical energy by the gas molecules is detected as sound waves by a microphone. The characteristics of this acoustic signal are then used to determine the gas concentration.

Note 2 to entry: Strictly speaking, this is not a photometric measurement, since the detector is not an optical device, however, this technique has been included due to the fact that it is well known and uses optical excitation to generate the signal.

3.16
analyzers using light emission
analyzers which detect the amount of light emitted by a sample gas at a particular wavelength or wavelength range after being artificially excited, in order to determine the concentration of a component species

Note 1 to entry: The excitation of the gas of interest may occur by several different methods, examples of which are shown in 3.16.1, 3.16.2 and 3.16.3.

3.16.1
fluorescence analyzer
analyzer which measures gas-component concentrations by detecting the emission of radiation from excited state molecules on relaxation to a lower energy state

Note 1 to entry: This may be a steady state or time-resolved measurement. The components that cause excitation are part of the analyzer.

Note 2 to entry: Fluorescence can occur when molecules absorb short-wavelength radiation, an electron is excited to a higher energy level and subsequently relaxes with emission of radiation.

Note 3 to entry: Chemiluminescence analyzers utilize a chemical reaction to produce molecules in an excited state.

Note 4 to entry: The component concentration may be measured directly by excitation of the component of interest or may be deduced by the quenching (reduction in excited state lifetime) by the component of interest of another excited state molecule present.

3.16.2
plasma emission analyzer
analyzer for gas measurement using light emission from an artificially generated plasma

Note 1 to entry: A plasma is generated within the sample background gas.

Note 2 to entry: Impurities within a sample gas may be determined by measuring the light detected at particular wavelengths from emission due to those impurities after excitation from the plasma.

Note 3 to entry: An impurity within a sample gas may be deduced by the quenching (reduction in excited state lifetime) by the impurity of interest of another excited state molecule present.

3.16.3
infrared emission spectroscopy
method for gas measurement detecting the amount of light emitted by a gas of interest in the range 0,7 μm and 50 μm after being artificially excited in order to determine its concentration

Note 1 to entry: A gas sample is artificially excited to produce light emission in the infrared range from the gas of interest, which is then detected and measured by a variety of techniques, including FTIR and under continuous and time-resolved configurations.

Documents
Document Sharing Hub
Full document details: IEC 61207-6 2014

3.17
analyzers using scattered light
analyzers which detect the scattered light from a light source after being passed though a sample gas in order to obtain both qualitative and quantitive information

3.17.1
Raman analyzer
analyzer for gas measurement using inelastic scattering of monochromatic light from a laser

Note 1 to entry: Raman spectroscopy is a spectroscopic technique used to study vibrational and rotational modes in a system. It relies on inelastic scattering (Raman scattering) of monochromatic light from a laser. The laser light interacts with molecular excitations in the system, resulting in the energy of the laser, photons being shifted up or down. The shift in energy gives information about the excitation modes in the system. This can also be used for quantitative measurements.

4 Procedure for specification

4.1 General

The procedures for specification are detailed in IEC 61207-1. This covers:

– specification of values and ranges;
– operation and storage requirements;
– limits of uncertainties;
– recommended standard values and ranges of influence quantities (see IEC 60654).

In this part of IEC 61207, specifications of ranges for ancillary equipment are given. Additional terms for specification of performance, and important aspects of performance relevant to photometric analyzers, are also detailed. The following documents may also be referred to where appropriate: IEC 60079-29-1 and IEC 60079-29-4.

4.2 Specification of essential ancillary units and services

The following should be specified where appropriate:

a) auxiliary supply requirements (e.g. compressed air, reference gases);
b) facilities for in-situ calibration or electronic and optical integrity checking;
c) facilities for automatic compensation for gas temperature or pressure variations;
d) methods and frequency of essential maintenance (e.g. cleaning of optical components or replacement of integral filter elements on across-duct or in situ analyzers).

4.3 Additional terms related to the specification of performance

To utilize a photometric analyzer, the gas to be measured shall be presented to the analysis system under defined conditions. The point in the system where these conditions are defined will vary, depending on the type of system. This standard refers to the analyzer as well as all parts subsequent to this point of application, which can be as follows:

– for an across-duct analyzer; the gas between the source and detector units, or source/detector unit and retro-reflector;
– for an in situ analyzer; the gas environment within which the measurement path is placed;
– for a dilution sampling system; the gas environment within which the dilution element is placed, that is normally the end of the probe;
– for an extractive system; the point at which the gas passes from the sampling system (not covered by this part) to the analyzer unit containing the optical cavity.

The following additional statements (a) to (f) are required to define the performance of the analyzer in terms of the conditions at this point of application:

AVA Documents
Document Sharing Hub
Full document details: IEC 61207-6 2014